2100 Pennsylvania Avenue, N Washington, DC 20037-3213 T 202.293.7060 ✓ F 202.293.7860

> 1010 El Camino Real Menlo Park, CA 94025-4345 T 650.325.5800 F 650.325.6606

Toei Nishi Shimbashi Bldg. 4F 13-5 Nishi Shimbashi 1-Chome Minato-Ku, Tokyo 105-0003 Japan

> T 03.3503.3760 F 03.3503.3756

www.sughrue.com

**BOX PATENT APPLICATION** 

Commissioner for Patents Washington, D.C. 20231

Re:

hbernstein@sughrue.com

Application of Eiichi KITAZUME

METAL MASK STRUCTURE AND METHOD FOR MANUFACTURING THEREOF

**Assignee: NEC CORPORATION** 

Our Ref. Q65909

Dear Sir:

Attached hereto is the application identified above including 25 sheets of the specification, including the claims and abstract, 4 sheets of drawings, executed Assignment and PTO 1595 form, and executed Declaration and Power of Attorney.

August 23, 2001

The Government filing fee is calculated as follows:

TOTAL FILING FEE
Recordation of Assignment
TOTAL FEE

**\$710.00** \$40.00 **\$750.00** 

Checks for the statutory filing fee of \$710.00 and Assignment recordation fee of \$40.00 are attached. You are also directed and authorized to charge or credit any difference or overpayment to Deposit Account No. 19-4880. The Commissioner is hereby authorized to charge any fees under 37 C.F.R. §§ 1.16 and 1.17 and any petitions for extension of time under 37 C.F.R. § 1.136 which may be required during the entire pendency of the application to Deposit Account No. 19-4880. A duplicate copy of this transmittal letter is attached.

Priority is claimed from August 25, 2000 based on Japanese Application No. 2000-255781. The priority document is enclosed herewith.

Respectfully submitted,

SUGHRUE, MION, ZINN,

\_MACPEAK & SEAS, PLLC

Attorneys for Applicant

By: // // Bernstein

Registration No. 25,665

